

## Wide bandgap semiconductor devices based on silicon carbide may revolutionize electronics

April 28 2020



Cubic silicon carbide. Credit: Giuseppe Fisicaro

Growth of high-quality substrates for microelectronic applications is one of the key elements helping drive society toward a more sustainable green economy. Today, silicon plays a central role within the semiconductor industry for microelectronic and nanoelectronic devices.



Silicon wafers of high purity (99.0% or higher) single-crystalline material can be obtained via a combination of liquid growth methods, such as pulling a seed crystal from the melt and by subsequent epitaxy. The catch is that the former process can't be used for the growth of silicon carbide (SiC), because it lacks a melting phase.

In the journal *Applied Physics Reviews*, Giuseppe Fisicaro and an international team of researchers, led by Antonio La Magna, describe a theoretical and experimental study of the atomic mechanisms governing extended defect kinetics in cubic SiC (3C-SiC), which has a diamondlike zincblende (ZnS) <u>crystal structure</u> that manifests both stacking and anti-phase instabilities.

"Development of a technological framework for the control of crystalline imperfections within SiC for wide bandgap applications can be a game-changing strategy," said Fisicaro.

The researchers' study pinpoints the atomistic mechanisms responsible for extended defect generation and evolution.

"Anti-phase boundaries—planar crystallographic defects representing the contact boundary between two crystal regions with switched bonds (C-Si instead of Si-C)—are a critical source of other extended defects in a plethora of configurations," he said.

Eventual reduction of these anti-phase boundaries "is particularly important to achieve good-quality crystals that can be used in <u>electronic</u> <u>devices</u> and enable viable commercial yields," said Fisicaro.

So they developed an innovative simulation Monte Carlo code based on a <u>superlattice</u>, which is a spatial lattice that contains both the perfect SiC crystal and all crystal imperfections. It helped "shed light on the various mechanisms of defect-defect interactions and their impact on the



electronic properties of this material," he said.

Emerging wide bandgap semiconductor devices, such as the ones built with SiC, are significant because they have the potential to revolutionize the power electronics industry. They are capable of faster switching speeds, lower losses and higher blocking voltages, which are superior to those of standard silicon-based devices.

Huge environmental benefits are also involved. "If the world's silicon power devices used within this range with were replaced by 3C-SiC devices, a reduction of  $1.2 \times 10^{10}$  kilowatts per year could be obtained," Fisicaro said.

"This corresponds to a reduction of 6 million tons of carbon dioxide emissions," he said.

The researchers concluded that the low cost of the 3C-SiC heteroepitaxial approach and the scalability of this process to 300-millimeter wafers and beyond make this technology extremely competitive for motor drives of electric or hybrid vehicles, air conditioning systems, refrigerators, and light-emitting diode lighting systems.

**More information:** "Genesis and evolution of extended defects: The role of evolving interface instabilities in cubic SiC," *Applied Physics Reviews* (2020). DOI: 10.1063/1.5132300

## Provided by American Institute of Physics

Citation: Wide bandgap semiconductor devices based on silicon carbide may revolutionize electronics (2020, April 28) retrieved 2 May 2024 from <u>https://phys.org/news/2020-04-wide-bandgap-semiconductor-devices-based.html</u>



This document is subject to copyright. Apart from any fair dealing for the purpose of private study or research, no part may be reproduced without the written permission. The content is provided for information purposes only.